

L Number	Hits	Search Text	DB	Time stamp
15	2	solder adj ball\$1 same dual adj damascene	USPAT	2003/06/09 16:15
40	0	20020140069.URPN.	USPAT	2003/06/09 16:29
41	0	((insulati\$4 or dielectric) near layer near5 (bump or ball) and semiconductor) and (redistribut\$ and ball and semiconductor) and laser near5 photolithography	USPAT; US-PGPUB	2003/06/09 16:33
42	43	((insulati\$4 or dielectric) near5 (bump or ball) and semiconductor) and redistribut\$	USPAT; US-PGPUB	2003/06/09 16:41
43	0	((insulati\$4 or dielectric) near5 (bump or ball) near5 (equal\$1 or "same") near5 (via or opening or trench)and semiconductor) and redistribut\$	USPAT; US-PGPUB	2003/06/09 16:43
44	2	((insulati\$4 or dielectric) near5 (bump or ball) near5 (equal\$1 or "same") near5 (via or opening or trench)and semiconductor)	USPAT; US-PGPUB	2003/06/09 16:53
45	21311	lattin adn redistribut\$	USPAT; US-PGPUB	2003/06/09 16:53
46	11	lattin and redistribut\$	USPAT; US-PGPUB	2003/06/09 16:53
-	7	("3907620" "5874770" "5933752" "6025647" "6111317" "6121104" "6197613").PN.	USPAT	2003/06/06 10:33
-	66	industrial adj technology adj research adj institute and solder	USPAT	2002/09/08 16:05
-	222	chu near10 lu	USPAT	2002/09/09 08:14
-	3	chu near10 lu and i/o	USPAT	2002/09/09 08:14
-	516	438/462	USPAT	2002/09/09 08:57
-	327	(438/462).CCLS.	USPAT	2002/09/09 08:58
-	1	"20020163069"	USPAT; US-PGPUB	2003/06/05 11:40

-	295	("6091140" "6236108" "6064111" "6201707" "5751063" "5894108" "6005289" "6117710" "6215169" "6215169" "6249135" "6250606" "6256875" "6326701" "6400018" "6545366" "6555459" "5918796" "6284353" "6448647" "6011304" "6187680" "5892271" "5990543" "5455456" "5786239" "5791911" "5889323" "5889321" "5903052" "5940966" "5982033" "6043100" "6086383" "6177731" "6184586" "6207478" "6226175" "6226175" "6333559" "6348741" "6429372" "5717252" "5933752" "5532186" "5719448" "6313532" "6429096" "6122172" "5477419").pn. ("5837154" "5866948" "6023097" "6028358" "6031292" "6034425" "6038135" "6121686" "6228466" "6232661" "5188280" "5463255" "5602059" "5736780" "5864173" "5866940" "5886399" "5892288" "5994768"	USPAT; US-PGPUB	2003/06/05 11:42
Search History 6/9/03 6:04:09 PM Page 2 C:\APPS\east\workspaces\10826392 redistribution electrode.wsp				

-	0	20010011764.URPN.	USPAT	2003/06/05 16:10
-	19	("4462534" "5024372" "5220200" "5261593" "5293067" "5346861" "5381848" "5388327" "5455390" "5504277" "5539153" "5541460" "5547740" "5564617" "5604379" "5608262" "5701032" "5736456" "5814894").PN.	USPAT	2003/06/05 16:18
-	0	6441487.URPN.	USPAT	2003/06/05 16:19
-	435	(insulati\$4 or dielectric) near layer near5 (bump or ball) and semiconductor	USPAT; US-PGPUB	2003/06/06 10:28
-	548	redistribut\$ and ball and semiconductor	USPAT; US-PGPUB	2003/06/06 11:58
-	408	((insulati\$4 or dielectric) near layer near5 (bump or ball) and semiconductor) not (redistribut\$ and ball and semiconductor)	USPAT; US-PGPUB	2003/06/06 10:34
-	1	"5323051".PN.	USPAT	2003/06/06 11:00
-	0	6400021.URPN.	USPAT	2003/06/06 11:01
-	443	((insulati\$4 or dielectric) near layer near5 (bump or ball) and semiconductor) or (redistribut\$ and ball and semiconductor) and laser near5 photolithography	USPAT; US-PGPUB	2003/06/09 16:32
-	12	((insulati\$4 or dielectric) near layer near5 (bump or ball) and semiconductor) or (redistribut\$ and ball and semiconductor)) and laser near5 photolithography	USPAT; US-PGPUB	2003/06/06 12:29
-	16	laser near5 photolithography and (mj or J or Joule\$4) near2 cm\$4	USPAT; US-PGPUB	2003/06/06 12:36